## Notice of References Cited Application/Control No. 10/705,205 Examiner DEWANDA SAMUEL Applicant(s)/Patent Under Reexamination CHOI ET AL. Page 1 of 1

## U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-6,587,680	07-2003	Ala-Laurila et al.	455/411
*	В	US-7,103,359	09-2006	Heinonen et al.	455/436
*	С	US-2004/0039817	02-2004	Lee et al.	709/225
*	D	US-6,061,563	05-2000	Lee, Myung-Hwan	455/435.1
*	Е	US-6,360,264	03-2002	Rom, Raphael	709/227
*	F	US-6,332,077	12-2001	Wu et al.	455/432.1
	G	US-			
	Ι	US-			
	-	US-			
	٦	US-			
	K	US-			
	┙	US-			
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
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	Ø					
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)					
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